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February 21, 2005

CERTIFICATE OF MAILING
37 C.F.R 1.8

I certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: MS Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date below:

February 21, 2005

Date

Michael C. Barrett

Michael C. Barrett

MS AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

RE: *U.S. Patent Application No. 10/779,319 entitled "EXTENDED DEPTH OF FOCUS MICROSCOPY" – Michael E. Dresser and Jose-Angel Conchello*
Our reference: OMRF:014US
Client reference: 2002-011-001

Sir:

Enclosed for filing in the above-referenced patent application is a Supplemental Information Disclosure Statement, Form PTO-1449, and references C39-C41.

No fees are believed to be due in connection with the filing of this Disclosure Statement, however, should any fees under 37 C.F.R. §§ 1.16 to 1.21 be deemed necessary for any reason relating to the enclosed materials, the Commissioner is authorized to deduct the appropriate fees from Fulbright & Jaworski Deposit Account No.: 50-1212/OMRF:014US.

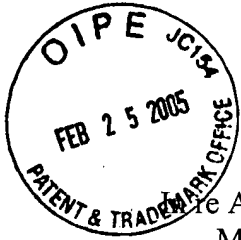
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Respectfully submitted,

Michael C. Barrett

Michael C. Barrett
Reg. No. 44,523

MCB/kvp
Encl.: as noted



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re Application of:
Michael E. Dresser
Jose-Angel Conchello

Serial No.: 10/779,319

Filed: February 13, 2004

For: EXTENDED DEPTH OF FOCUS
MICROSCOPY

Group Art Unit: 2621

Examiner: Unknown

Atty. Dkt. No.: OMRP:014US

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February 21, 2005
Date

Michael C. Barrett
Michael C. Barrett

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

MS AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56, it is respectfully requested that this Supplemental Information Disclosure Statement be entered and the documents listed on attached Form PTO-1449 be considered by the Examiner and made of record. Copies of the listed documents required by 37 C.F.R. § 1.98(a)(2) are enclosed for the convenience of the Examiner.

In accordance with 37 C.F.R §§ 1.97(g), (h), this Supplemental Information Disclosure Statement is not to be construed as a representation that a search has been made, and is not to be

construed to be an admission that the information cited is, or is considered to be, material to patentability as defined in 37 C.F.R. § 1.56(b).

The present Supplemental Information Disclosure Statement is being filed prior to the receipt of a first Official Action reflecting an examination on the merits, and hence is believed to be timely filed in accordance with 37 C.F.R. § 1.97(b). No fees are believed to be due in connection with the filing of this Supplemental Information Disclosure Statement, however, should any fees under 37 C.F.R. §§ 1.16 to 1.21 be deemed necessary for any reason relating to these materials, the Commissioner is authorized to deduct the appropriate fees from Fulbright & Jaworski Deposit Account No.: 50-1212/OMRF:014US.

Applicants respectfully request that the listed documents be made of record in the present case.

Respectfully submitted,



Michael C. Barrett
Reg. No. 44,523
Attorney for Applicants

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600 Congress Avenue, Suite 2400
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Date: February 21, 2005

Form PTO-1449 (modified)

Atty. Docket No.

Serial No.

OMRF:014US

10/779,319

List of Patents and Publications for Applicant's

Applicant

Michael E. Dresser

Jose-Angel Conchello

INFORMATION DISCLOSURE STATEMENT

Filing Date:

Group:

February 13, 2004

2621

(Use several sheets if necessary)

U.S. Patent Documents

Foreign Patent Documents

Other Art

See Page 1

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U.S. Patent Documents

Exam. Init.	Ref. Des.	Document Number	Date	Name	Class	Sub Class	Filing Date of App.

Foreign Patent Documents

Exam. Init.	Ref. Des.	Document Number	Date	Country	Class	Sub Class	Translation Yes/No

Other Art (Including Author, Title, Date Pertinent Pages, Etc.)

Exam. Init.	Ref. Des.	Citation
	C39	Hausler, "A method to increase the depth of focus by two step image processing," <i>Optics Communications</i> , 6(1):38-42, 1972.
	C40	Hausler and Korner, "Imaging with expanded depth of focus," <i>Zeiss Information</i> , 29:9-13, 1987.
	C41	Holmes <i>et al.</i> , "Increased depth of field and stereo pairs of fluorescence micrographs via inverse filtering and maximum-likelihood estimation," <i>Journal of Microscopy</i> , 164(Part 3):217-237, 1991.

25504168.1

EXAMINER:

DATE CONSIDERED:

EXAMINER: INITIAL IF REFERENCE CONSIDERED, WHETHER OR NOT CITATION IS IN CONFORMANCE WITH MPEP609; DRAW LINE THROUGH CITATION IF NOT IN CONFORMANCE AND NOT CONSIDERED. INCLUDE COPY OF THIS FORM WITH NEXT COMMUNICATION TO APPLICANT.